



PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 2823**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Koji SUZUKI

Group Art Unit: 2823

Application No.: 09/970,763

Examiner: B. Kebede

Filed: October 5, 2001

Docket No.: 110596

For: METHOD FOR MONITORING DEPOSITION REACTION DURING PROCESSING
THE SURFACE OF A SEMICONDUCTOR SUBSTRATE

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the December 17, 2003 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.